

# Elveflow User Guide SEQUENTIAL FLUID INJECTION PACK

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## Introduction

The **sequential injection pack** offered by Elveflow is designed to allow optimal use by anyone, whether they are already familiar with microfluidics and fluid handling automation or have never used it before. Simple and intuitive instructions are provided to quickly and easily inject various solutions or samples sequentially in a microfluidic line and control the injected volumes.

When starting out, the user can follow the provided protocol step by step to **inject sequentially up to 12 solutions in a device**.

Numerous tips are provided throughout the document. Finally, the appendices provide numerous information to master the injection technique, automate the process and control the injected volumes to fully master the versatility offered by this sequential injection system.



The sequential injection system involves two principal elements: **a pressure controller** and a **rotary valve**. The function of the pressure controller is to accurately pressurize the different reservoirs containing the various liquids. Once pressurized, the liquids can be connected to the rotary valve which is used as a selector. The rotation of the valve allows the user to choose the liquid which goes through the valve into the system. Refer to the following videos to visualize the <u>working principle</u> and <u>outcome of such injection</u>.



The setup presented in this user guide is an example where 5 different solutions are injected in a microfluidic chip. This flexible and versatile setup can be adapted to any user requirement. Tips and tricks are given throughout the document to tailor the setup and for example adapt the number of solutions injected, automate the system and set up a fast liquid swap, etc.

If your requirements are not fully met using the information provided in the guide, please feel free to contact us at **contact@elveflow.com**.

Non exhaustive list of applications for which the sequential injection pack can be used:

> Cell culture under flow

spaced by oil

Four different aqueous solutions

- > Functionalization, characterization or test of sensors
- > Calibration of sensors
- > Toxicity or drug screening

- > Gradient assay
- > Perfusion
- Fluorescence In Situ Hybridization (FISH)
- > Any application that involves automated and/or fast medium switching



Schematic of the sequential injection setup for the injection of 5 different solutions in a microfluidic chip

## **Contents of the sequential injection pack**

## 1 OB1 MK3+ Pressure controller

1 channel with 0 to 2 bar range

The pressure controller is the centerpiece of the setup; it enables the precise control of the pressure difference across the fluidic system and thus accurate control of the liquid flow.



**Other pressure ranges are available, also including vacuum control.** Depending on the requirements of your experiment, you can choose between different pressure ranges : 0 to 200 mbar, 0 to 2000 mbar, 0 to 8000 mbar, -900 to 1000 mbar and -900 to 6000 mbar.

## PRINCIPLE OF PRESSURE-DRIVEN FLOW RATE CONTROL

Elveflow instruments use pressure to drive liquid flows in fluidic systems

The elementary principle is that a pressure difference across a fluidic line (between the outlet and the inlet of the fluidic system :  $\Delta P$ = Pout-Pin) generates movement of the liquid in the system characterized by its volumetric flow rate. The flow rate Q is proportional to the pressure difference, and the proportionality coefficient R is called the fluidic resistance:

#### $\Delta P = R \times Q$

R depends on the geometrical characteristics of the fluidic system and on the properties of the liquid.

For instance: the longer or the thinner the tubing or the more viscous the liquid, the greater the resistance. It means that a higher pressure difference is required to obtain the same flow rate in a system with longer or thinner tubing or with a more viscous liquid.

For instance the resistance of a circular cross channel is

$$R \propto \frac{\mu L}{r^4}$$
 radius

Each element of the circuit (chip, tubing, sensors, ...) contributes to the whole resistance R of the system.



The OB1 pressure controller creates and controls the

pressure difference by pressurizing the air in a sealed

reservoir that contains the liquid at the inlet of the system.

4. Microflui The 081 p vacuum cor best perfect flow



A **flow rate sensor** can be added in line to measure and monitor the flow rate Q.

**IN PRESSURE CONTROL:** the user controls the pressure difference (the command is a pressure) and it generates a flow rate.

**IN FLOW RATE CONTROL:** the user sets the flow rate (the command is a flow rate) and the system continuously adapts the applied pressure difference so that the flow rate Q meets its target.

You can refer to this video to learn more about pressure-driven flow control https://youtu.be/niWfINDUub4

3. Pressurized reservoir holder rack

Push your si





### **1 MUX Distribution**

12/1 bidirectional microfluidic valve

The rotary valve is the second highlight of the setup. This instrument can switch between up to 12 liquids. It enables the injection of 1 sample into 12 outputs or 12 samples into 1 output. Used with the pressure controller, it allows the sequential injection of solutions in a microfluidic system.

## 1 Manifold

It enables merging or splitting microfluidic liquid or gas lines. When a port is not used, it has to be plugged with a plug fitting (included with the manifold) to avoid any leakage. Several manifolds can be added in series to merge or split as many lines as required.







## 1 Flow rate sensor (optional)

The flow rate sensor measures the flow rate of the liquid going through the sensor.

Used with the pressure controller, it enables the monitoring and control of the flow rate. Different flow sensors are available in the Elveflow product range corresponding to different ranges of flow rate detection. Your choice of flow sensor will depend on the requirements of your experiment including injected volumes, flow rates, types of liquids...

For example, if multiple solutions with various properties are involved, working with a coriolis force based flow sensor (BFS) is highly advised to avoid laborious calibration steps thanks to its compatibility with nearly any solution.

Feel free to reach out to us at contact@elveflow.com if you have any questions.

#### Reservoirs

All the liquids are stored in reservoirs. A different reservoir is required for each solution.

Six different volumes of reservoirs from Eppendorf ( $\mu$ L) to bottles with GL45 caps (L) are available, allowing versatility in your volume operations.



## Starter Pack Kit

All the following items are included in our Starter Pack. It will help you to easily set up your system and connect all its components together:

Refer to **appendix 1** for a visual guide to connections

## 1 PTFE Tubing 1/16" OD 1/32" ID

The liquid passes through the tubing to go from one component (such as reservoirs, MFS, microfluidic device...) to another. The internal diameter equals 1/32" or 794 µm. The outer diameter equals 1/16" or 1590 µm. Other tubing sizes are available on request.



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### Fluidic resistance tubes

The fluidic resistance are tubes with small diameters, which will help to achieve better and more stable control of the flow rate. The higher the resistance, the higher the pressure (from the OB1) to get a given flow rate. Unions (see connection kit below) are necessary to connect the microfluidic resistances with the rest of the system.



To learn more about resistance https://support.elveflow.com/support/solutions/articles/48001142611-set-a-flow-control-feedback-loop-resistance-and-pid-tuning-

## **1 Microfluidic connection kit**

These pieces are mandatory to connect the different components with the tubing.

Refer to **appendix 1** for a visual guide to connections



Union



Fittings 1/4"-28 flat-bottom fittings to block one or more ports of the manifold



Fittings for the pneumatic tubing



Fittings 1/4"-28 to 1/16" OD fittings for the tubing



Luer lock filter



Pressure source connection kit



## **Pneumatic tubing**

This tubing is used to connect the OB1 pressure outputs to the reservoirs.



#### 1 air filter

The air filter is placed between the pressure generator (e.g. compressor) and the OB1 inlet. It keeps the OB1 clean from dust and humidity.

#### **1 Tubing cutter**

The cutter is useful to properly cut the tubing (burr-free perpendicular cut). It helps to prevent leaks in your setup.





DOWNLOAD THE LATEST VERSION OF ESI SOFTWARE FOR FREE

### ESI software

All the elements of the system can be controlled thanks to the ESI software: the OB1 parameters, the rotation of the valve, etc.

Its interface allows you to easily set the pressure or flow rate you wish to apply to the system, as well as select the rotary valve port to inject the selected liquid.

It also includes a built-in sequencer for easy system automation. The provided set of SDKs in C, LabVIEW, Matlab and Python can be used for further automation and integration into larger systems.

Refer to appendix 4 for more information on automation



#### The pressure source is an option to the pack.

The OB1 should be connected to a pressure supply. The optimal pressure source has to deliver a pressure higher than the maximum pressure of your OB1 channel (or at least 1.5 bar), and a maximum of 10 bar.

For example, if you are using a 0-2 bar pressure channel, working with a pressurized source delivering 2,5 bar is required to cover the whole pressure range. Refer to the <u>OB1 user guide</u> for more information and feel free to contact us at **contact@elveflow.com** to help you pick the optimal pressure source for your system and provide the pressurized air source if needed.





Before starting the experiment

## Before starting the experiment



To be calibrated, the OB1 must be connected to a pressure source, to the computer with the ESI software, and plugged to the power supply.

Once the OB1 is correctly connected, switch it on by pressing on the front panel button, close all its channels using the provided plugs, add it to the software and perform its first calibration.

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Don't forget to set up the provided filter between the pressure source and the OB1.



Refer to the OB1 user guide for detailed instructions | Instrument connection



You can refer to this video https://www.elveflow.com/ microfluidic-applications/ setup-microfluidic-flow-control/ ob1-pressure-controller-install-box/#firstcalib

It is important to calibrate the OB1 the first time it is added to the ESI software. Once done, it is not necessary to calibrate it before each experiment, unless you observe pressure drifts or if you change the pressure source.

Once your OB1 is calibrated, you can connect it to any other component of the system to perform experiments.

See Appendix 1 for details on connecting each part of the microfluidic system







When you open the **MUX Distribution window** (arrow next to the instrument in the main window of the ESI), a noise might be heard.

To simplify your workflow, it is advised to rename the ports in the MUX Distribution window according to the solutions they are connected to. This is especially recommended if you are working with numerous samples.





Let's start injecting different solutions sequentially!

## Let's start injecting different solutions sequentially!

## 1 Setup installation

Refer to appendix 1 to see how to connect all the components together



#### Connection to the manifold



To start with, connect **the central port of the manifold to the OB1 channel output**, using the 4mm OD coil tubing. Then, connect each of the reservoirs to one of the outer ports of the manifold using 1/4"-28 thread to 3/32" OD barb fittings (black and transparent fittings).

If you are not using some ports of the manifold, close them using microfluidic plugs PFA 1/4"-28 flat-bottom fittings provided with the manifold.

#### MUX Distribution connection and preparation

#### Connections



**Connect all the reservoirs** containing the solutions to the outer ports of the MUX Distribution by using the supplied 1/16" OD tubing and the 1/4"-28 to 1/16" OD fittings. At the outlet of the MUX Distribution, connect one piece of the supplied 1/16" OD tubing using the 1/4"-28 to 1/16" OD fitting and place the other end to a waste reservoir.





In order to simplify screwing the fittings to the MUX Distribution, don't hesitate to move the instrument in order to face the hole with the fitting.

#### Remove air from the tubing

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On the MUX Distribution window, select port #1 and set a low pressure to fill the tubing with the liquid (e.g 50 mbar). Once liquid gets out to the waste, air is completely removed from the system and you can switch to the next liquid.



If no liquid comes out of the MUX Distribution, refer to the **Troubleshooting** section

## **A**

It is advised to plug the unused ports of the rotary valve with 1/4"-28 flat-bottom fittings provided with it.



To remove bubbles from the tubing and fill the tubing faster, it is recommended to fill the tubing from the reservoir to the MUX Distribution outlet by setting a low mbar command on the OB1. When the interface reaches the tubing extremity, set the pressure to zero. It is quicker to fill if you have the exit of the MUX directly over a waste rather than connected to all the modules that follow

Repeat step 2 for all the different solutions connected to the MUX Distribution by selecting the corresponding port on the MUX Distribution window. A noise is heard during the rotation of the valve.



It is also possible to introduce a 3/2 valve at the outlet of the MUX Distribution in order to flush the MUX from air or a waste solution. Refer to the "Going further" section, appendix 7, for more information.

![](_page_10_Figure_14.jpeg)

#### **Device connection**

Connect the tubing of the MUX Distribution outlet (or the flow sensor outlet if you plan to control or monitor the flow rate) to the corresponding inlet of your device.

To keep reducing the formation of bubbles and keep shortening the initial filling time, it can be now useful to fill the tubing from the MUX Distribution outlet to the device with liquid before connecting the device. To do so, repeat the same steps as stated earlier to remove the air from the tubing arriving at the MUX Distribution. Set a low mbar command on the OB1 and watch the liquid interface going through the tubing, set the pressure to zero when the

Connect another tubing to the outlet of the device and place the other end of the tubing in a waste reservoir.

interface reaches the tubing extremity then connect the extremity to the device.

## 2 System control: sequential injection

Now that **all the reservoirs are filled with their respective liquids** and all the components are connected together (OB1, manifold, reservoirs, MUX Distribution, device), **switch on** the OB1 pressure controller and the MUX Distribution and launch the ESI software.

Open the OB1 and the MUX Distribution windows in the ESI as introduced in the "Setup Installation" section.

![](_page_11_Picture_7.jpeg)

1. Select a port on the MUX Distribution window. In the example, the red solution is injected into the system.

- 2. Set the channel pressure to a given value until the microfluidic device is filled. The pressure is set to 50 mbar in the example.
- 3. To change the solution injected to the device, go back to the MUX Distribution window and **select another port**. The valve rotates (a noise can be heard), another solution is selected and injected.

## **CONGRATULATIONS**, YOU HAVE SEQUENTIALLY INJECTED DIFFERENT SOLUTIONS!

Browse the appendices to discover many useful tips and guides for taking full advantage of the versatility offered by this system, e.g. control by flow rate (Appendix 2), or achieve precise control over an injected volume (Appendix 3).

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## ΠP

For a faster switch between liquids, place your device as close as possible to the MUX Distribution. This also allows more accurate control of the injected volumes with lower sample volumes If the solutions are not injected in the system in the order they are connected to the rotary valve, be aware of possible cross contamination. In fact, when switching between two non consecutive ports and depending on the pressure/flow rate applied, the valve takes a small volume of all the solutions connected to the ports in between. As a result, the first volume going out of the valve is a heterogeneous solution. Refer to the "Going further" section, appendix 7, to find information on how to solve this issue by adding valves to the microfluidic line.

### 3

## **Technical specifications**

The sequential injection system is designed to easily inject different solutions in a microfluidic device. User friendly and versatile, the system's main characteristics and options are summarized in the following table.

SEQUENTIAL INJECTION SYSTEM	SPECIFI	CATIONS
Range of pressure	0-7	bar
Range of flow rates	from 70 nL/min to 5 mL/min	from 1.6 µL/min to 500 mL/min
Type of liquids	With MFS: 2 calibrations (water and IPA)	With BFS: any liquids
Switching time	With pressure control: 150 ms	With flow control: 1-2 s (depending on your system's parameters)
Number of solutions	from 1 to	about 150
Wetted materials	PCTFE and PTFE	
Operating temperature	5 °C tr	2 40 °C
Operating humidity	20 to 70 %	condensing

## лD

Some important but quick variations of the flow rate are observed each time the MUX Distribution valve rotates, especially when the flow rate is steady. To learn more about it, refer to the "Troubleshooting" section.

## **IP**

In order to decrease the impact of the mechanical switch of the rotary valve on the stability of the flow rate, we advise to set the pressure (or the flow rate) back to zero, then apply the switch of ports on the MUX Distribution and set back the pressure (or flow rate) to the targeted value. Refer to appendix 9 of the "Going further" section for more tips.

![](_page_13_Picture_1.jpeg)

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## After the injection

Once your experiment is finished, make sure to empty the tubings and clean the rotary valve by flushing at least distilled water in all the lines of the valve, followed by air drying. This procedure is sufficient to clean the tubings and valve from **aqueous or oil solutions**.

#### REFER TO ANOTHER USER GUIDE

MUX Distrib user guide | for more information on cleaning procedures **if you work with other solutions** 

![](_page_13_Picture_6.jpeg)

JF

To dry the rotary valve, connect a reservoir filled with air to the valve. Pushing air allows you to remove the remaining solution stuck in the valve. You can also work with gas and have reservoirs filled with different types of gas.

![](_page_13_Picture_9.jpeg)

Troubleshooting & Going further section

## Troubleshooting

### The MUX Distribution inlets/outlets leak

The reason is probably that the fittings are not tightened enough on the MUX Distribution valve.

Before applying a pressure to the microfluidic line, make sure to have tightened the fittings well enough. Be careful not to over tighten the connector though to avoid any long term damage.

## No solution comes out of the MUX Distribution

One reason could be that the port selected on the MUX Distribution is not the right one. First, check the selected port on the software.

If the problem remains, the issue is likely coming from the pressure (or flow rate) target set on the OB1 pressure controller window. The target is probably not high enough for the fluidic <u>resistance</u> of the system (or the fluidic resistance is too high, it depends on the point of view). Disconnect the tubing coming out of the MUX Distribution from the rest of the microfluidic line and check if the fluid flows correctly out of this tubing.

If the problem remains, it could be because the communication between the instrument and the software is interrupted. To restore the communication, you can :

(1) select another port and come back to the previous one,

(2) close the MUX Distribution window, open it again and select the port needed

or (3) click on the "refresh" button on the main window of the ESI. A noise should be heard during rotation if the MUX valve is rotating correctly.

## There are big jumps in the flow rate when the valve is rotating

When switching the valve, the flow rate first decreases when the flow is blocked. To compensate for this stop, the pressure increases and makes the flow rate overshoot the set value before going back to this value in less than 1s. So the observation of big jumps in the flow rate when the valve rotates is normal.

To learn how to lower the impact of the mechanical switch on the flow rate, refer to **appendix 9** of the **"Going further" section.** 

## There are bubbles in my tubing

One reason could be that some air was left in the tubing when you connected a new reservoir to the MUX Distribution.

If it is the case, disconnect the tubing going out from the MUX Distribution from the device or the flow sensor (depending on your setup), apply a low pressure and wait until the air is out. Once the solution is dripping, you can connect the tubing to the microfluidic line again. You can also refer to the MUX Distribution and preparation section for more information or add a bubble trap in your system if the problem is recurrent.

# The flow rate measured by my MFS suddenly drops for a short duration

The reason is probably that you have air bubbles in your system. When an air bubble passes through the MFS, the sensor measures a zero flow rate as long as the bubble is inside. To get rid of air bubbles, just wait for it to get out by maintaining a constant pressure. The initial filling of the system is critical to avoid bubbles.

## The flow rate is not stable

If the flow rate is not stable on the set value, first check that you have not forgotten to add some resistance tubing in the fluidic system. If it is not the cause of the problem, you should consider changing the values of the P and I parameters. The lower the value of P, the more stable the flow rate.

Appendix 2 of the "Going further" section details this solution.

You can also increase the microfluidic resistance. Refer to the "Going further" section, appendix 2 as well, for more information.

## The OB1 is very noisy

If your OB1 starts making loud noise, it is probably because of a leak in your system: the pressure source tries to permanently compensate for the lack of pressure due to the leak. Check all the connections of the system (using teflon tape is often useful to avoid leaks on fluidic and pneumatic connections).

![](_page_14_Picture_26.jpeg)

This application note is dedicated to the solution https://support.elveflow.com/support/solutions/articles/48001143505-fix ob1-continuous-noise-or-a-leak

# There is dust in my tubings or device/my microfluidic line is clogged

In case your microfluidic line starts to clog (dust, particles, etc), try to increase the pressure (or flow rate) to expel the dust from the line. If it does not work, you should change the resistance tubing. As its diameter is smaller than the rest of the tubings, it is generally the first to be clogged. Another solution might be to change the device you are working with. The presence of dust in the line should not be ignored. The flow rates can be impacted and the volumes injected will not match the expectations. Working with "clean" solutions and reservoirs is essential to prevent clogging. We highly advise to filter solutions before using them in a microfluidic line.

## **Going further**

The sequential injection pack is very flexible, and it might be beneficial to further customize your setup to perfectly fit your requirements.

For example, you might want to work with a specific system, or add more solutions to the setup to increase the versatility of the injection, or perform a complete automation of your injection system.

Be aware that even though it is not hard to adapt your setup to new experimental conditions, there are always a few elements to fine-tune to make sure your experiment works well!

The following appendices are dedicated to the improvements you could make to your system to further boost your experiment!

## Appendix 1Microfluidic connector guide

![](_page_15_Picture_7.jpeg)

![](_page_16_Picture_1.jpeg)

![](_page_17_Picture_1.jpeg)

### Appendix 2 Flo

#### Flow rate control

This section explains how to **directly control the system in flow rate**, through a feedback loop between the pressure controller and the flow sensor. In **feedback control mode** ("Sensor" mode), you can set a target flow rate, and the inlet pressure will automatically adapt to reach it. The feedback loop relies on a PID algorithm. The D parameter is preset but the gain parameter (P) and the integration parameter (I) can be tuned.

We advise you to use the "PI Basic" algorithm that will work for most applications. The user can use the autotune module to automatically find P and I parameters, or set these parameters manually to better match the requirements in terms of responsiveness and stability.

![](_page_18_Figure_5.jpeg)

![](_page_19_Picture_1.jpeg)

#### BFS: principle, advantages and specifications

The Bronkhorst Flow Sensor (BFS) is based on the Coriolis technology and presents unique benefits for your microfluidic experiments.

- Versatility: it works with any liquid and doesn't require any calibration to ensure its compatibility;
- High accuracy: up to 0,2% of the flow rate;
- Broad flow rate range: a single sensor measures from μL/min to mL/min (several ranges available from 1.6 μL/min to 500 mL/min);
- High flow rates accessible: up to 500 mL/min.

Be aware that this flow sensor is added to the software **as an instrument** and not as a sensor. To learn more, refer to the <u>dedicated webinar page</u> and the <u>Bronkhorst website</u>.

# WHY IS IT NECESSARY TO CALIBRATE THE MFS FOR LIQUIDS OTHER THAN WATER AND IPA?

MFS flow sensors measure the flow rate of a liquid by locally warming it (max 0.5 °C) and by measuring the temperature drop across the sensor capillary. For comparison, the BFS sensor works with the Coriolis force. The relationship between temperature and flow rate is highly dependent on the physical properties of the liquid passing through the MFS, which is why calibration is required. Two calibrations are natively implemented in the digital MFS : water and Isopropyl alcohol (IPA). The water calibration is suitable for all aqueous solutions. The IPA calibration is appropriate for use with liquids of any hydrocarbon chain length, with an additional linear adjustment through calibration.

A specification table gives all the corresponding flow rate ranges depending on the calibration for all the MFS flow sensors.

#### STEP 2

Once the MFS flow sensor is hooked up directly to the OB1, you can visualize the flow rate in your microfluidic setup.

Go to the OB1 window.

On the right part of the channel (grey rectangle), the flow rate is now indicated. Right above, the name of the flow sensor connected to the pressure channel appears.

![](_page_19_Picture_16.jpeg)

![](_page_19_Picture_17.jpeg)

To learn more about the different working principles of flow sensors

https://www.elveflow.com/microfluidic-reviews/microfluidicflow-control/microfluidic-low-flow-liquid-flow-meters-a-review/

STEP 3

The next task is to check the fluidic resistance of the setup and adapt it if necessary.

The addition of resistance tubing might be necessary in order to adapt the overall fluid resistance of your setup. If this is the case, the length and diameter of the resistance tubing need to be determined.

## ΓP

If you change the microfluidic device, flow sensor or the liquid in your setup, the fluidic resistance might be different. If so, you will have to adapt the length and/or diameter of the resistance used in the system, so that the range of the pressure controller matches the range of the flow rate sensor you work with.

## TP

When the fluidic resistance of the system is well dimensioned, it is possible to span the whole range of flow rates of the flow sensor with the range of pressure of the OB1, avoiding saturation of the flow sensor.

## TE

The resistance should always be placed downstream of the flow sensor (between the sensor and the device) to get the most stable measurements.

#### **STEP 4**

The last task is to **tune the P and I parameters** in order **to adapt the stability and responsiveness** of the flow rate to your requirements. Several algorithms are available.

Elveflow recommends using the "PI Basic" algorithm which gives good results for most of the applications.

First, we advise you to use the autotune of the ESI software. This option suggests a couple of P and I parameters giving a good balance between stability and responsiveness.

## WHY IS MICROFLUIDIC RESISTANCE IMPORTANT?

Adding the right amount of fluidic resistance in the fluidic path is important as it is the way to finetune the system's whole resistance R to obtain the best performance in terms of flow rate control. It allows to adjust R so that the range of accessible  $\Delta P$  (given by the range of the OB1 channel output) matches the range of the flow rate sensor used. Doing so, the system uses the whole dynamics of both the sensor and the regulator to control the flow rate.

For instance in a system (with a 2 bar OB1 channel) where R=R1 is too low, few mbar of  $\Delta P$  generate a high flow rate that can saturate the flow rate sensor. In other terms, a small part of the accessible  $\Delta P$  matches the full range of the sensor, it can lead to unstable flow control: a small  $\Delta P$  variation triggers a huge flow rate variation.

The solution is to add the right amount of fluidic resistance to increase R=R2 so that most of the range of the pressure regulator is used. As a result, a higher pressure is required to saturate the sensor, consequently a small  $\Delta P$  variation triggers a small flow rate variation and it allows to obtain a stable system.

![](_page_20_Figure_15.jpeg)

![](_page_20_Figure_16.jpeg)

However, the parameters proposed by the autotune option might not be the best for your experiment as this module has a tendency to give more importance to stability over responsiveness. So, if your experiment requires greater responsiveness, you might need to fine tune the parameters by hand in order to increase this specificity.

![](_page_20_Picture_18.jpeg)

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If you can't get the responsiveness and stability you aim at with the "PI Basic" algorithm, you might use the "PI large reservoir" algorithm instead. This second algorithm is more adapted for large volumes (lots of air).

## THE NEED FOR FEEDBACK: HOW TO FINE TUNE FEEDBACK PARAMETERS (P AND I)

There are **two main reasons** that will lead to a need for readjustment of the P and I parameters:

- You would like to monitor the responsiveness (P), the stability of the system (I), and/or find a greater balance between both depending on your requirements.
- You make changes to your experimental setup, especially to the resistance or liquids, which require P and I
  parameters to be optimized once more.

To make the necessary adjustments, the values of the feedback parameters can be fine tuned in several ways. For example, using the autotune option with the "PI Basic" algorithm on the setup presented in this user guide, the flow rate stabilized within 30 s after values of P and I were automatically selected.

With the "PI large reservoir" algorithm, stabilization time was even longer. However, after fine tuning the P and I parameters, it is possible to balance responsiveness and stability and get to the requested flow rate of 200  $\mu$ L/min in a couple of seconds.

Be aware that a sudden increase of the I parameter value on the "PI Basic" algorithm while controlling the flow rate ("Sensor" mode) will induce an overflow. It is recommended to change the value of I while controlling the pressure ("Regulator" mode) and then switch back to flow rate control.

You have too much overshoot? Decrease P!

The system reacts too slowly? Increase P!

The system reacts quickly but slows down as it approaches the target? Increase I!

You get some instabilities or too much oscillation? Decrease I!

#### 250 Autotune PI Basic (P=0,005, I=0,013) Autotune PI large reservoir Fluid Flow rate (µL/min) 200 (P=0,007, I=0,017) PI basic 150 (P=0,25, I=0,12) PI basic 100 (P=0,12, I=0,08) 50 0 'n 10 20 30 40 50 Time (s)

#### STEP 5

Now that the flow sensors are calibrated, the fluidic resistance and the P and I parameters of the system optimized, you are ready to start the feedback loop of flow rate control.

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Don't forget to make sure that the whole fluidic system is filled with liquid before switching to flow rate control mode.

**Choose the "Sensor" mode** (flow rate control instead of pressure control), and set the flow rate you want to reach (you are now controlling the flow rate instead of the pressure).

Refer to the appendix 3 If you want to watch volume injection live

![](_page_21_Figure_19.jpeg)

## TP

While the tubing is filled with air, you should control by pressure and not by flow rate. This is because a flow sensor filled with air will not measure a flow rate, and the OB1 will keep increasing the pressure until the fluid reaches the flow sensor. Reaching the maximum pressure of the channel pressure range should be avoided. Once the whole system is filled with liquid, it is safe to switch to flow rate control.

Moreover, instabilities in flow rate will appear if air bubbles flow in the circuit, especially through the flow sensor. We advise you to add a bubble trap before the flow sensor in your setup in order to solve the problem.

![](_page_22_Picture_1.jpeg)

The flow sensor is very sensitive to vibrations and movement perturbations so place it on a stable surface. Make sure the outlet reservoir is not totally empty and that the outlet tubing plunges into the solution. Otherwise, there will be dripping, which will affect the flow rate stability.

#### **REFER TO AN APPLICATION NOT**

![](_page_22_Picture_4.jpeg)

To learn more about the feedback loop, the choice of resistance tubing and the tuning of the P and I parameters

https://support.elveflow.com/support/solutions/ articles/48001142611-set-a-flow-control-feedbackloop-resistance-and-pid-tuning-

Once your experiment is finished, make sure to **empty the tubing and to properly clean the flow rate sensors** according to the cleaning procedures described in the Flow Rate Sensor user guides and <u>in the support section of the Elveflow website</u>.

## Appendix 3 Volume control – manual switching

#### Easily visualize the volume injected and switch between samples when a specific volume is reached

This section presents how to follow an injected volume in real time in a microfluidic device and easily control sequential injections.

This section describes **manual switching** between ports, which enables a rough estimate of injected volumes. Refer to **Appendices 4 and 10** for details on finer volume control using automated switching.

> Connect the **flow sensor to the MUX Distribution** using the panel on the right of the screen "**No sensor, Click to select**".

![](_page_22_Picture_13.jpeg)

![](_page_22_Picture_14.jpeg)

A new window appears, select the correct flow sensor and click on OK.

The flow sensor is now visible in the grey area, where "No sensor, Click to select" was previously visible.

Go back to the OB1 window and set a pressure.

Back to the MUX Distribution window, you can follow the volume injected through the selected port. If you don't need high precision, you can manually switch between the ports when the desired sample volume has been injected. In the example below, 10.69 µL of blue solution has been injected. The objective was to inject around 10 µL.

![](_page_23_Picture_2.jpeg)

#### "Flow integration" module

This module is useful when you want to inject a precise volume of solution into a device and follow the remaining volume in the initial reservoir.

![](_page_23_Figure_5.jpeg)

## **Appendix 4**

#### System automation

To easily automate experimental parameters (e.g. pressure, flow rate, injected volumes) for fluid injection, use the integrated sequence/ automation tool of the ESI software.

To learn more about the automation of sequences using the ESI software:

![](_page_24_Picture_5.jpeg)

For further integration into your system, you can also use the Software Development Kit (SDK) provided with the ESI software (available in LabVIEW, C++, Python and MATLAB).

For moreinformation regarding the automation using SDK, refer to the SDK user guide or send us an email at contact@ elveflow.com.

~

#### Automation using the sequencer

The sequencer included in the ESI software can be used to easily automate your sequential injection of liquids and/or control other parameters such as pressure, flow rate, volumes among others. The scheduler is built as a series of steps, each with a specific command such as load an instrument configuration or specify the length of the previous command.

Before building a sequence, it is recommended to create all the instrument configurations required for the experiment.

![](_page_24_Picture_11.jpeg)

![](_page_24_Picture_12.jpeg)

2

1

system.

Step 1 can be repeated for all needed configurations.

We advise you to control the flow rather than the pressure during your experiments for better accuracy. If flow is initially unstable, add a piece of flow resistance. Refer to Appendix 2 for more detailed information.

If you use different liquids and control the injection with the flow rate, be aware that the optimal P and I parameters might be different from one liquid to another. You can create different configurations for all the liquids. When saving the configurations, the algorithm parameters (P and I) will also be saved. However, when using the MFS sensors, be aware that the type of liquid the sensors are calibrated for can not be changed during a sequence. So if you work with aqueous solutions and IPA and want to automate your experiment, we recommend using a BFS sensor.

![](_page_25_Figure_1.jpeg)

We recommend choosing the shortest rotation in order to decrease the impact of the mechanical switch. To learn more about the impact of the switch, refer to appendix 9.

![](_page_26_Picture_1.jpeg)

To end the sequence: On the left side of the window, click on the green "OB1" box (a line "OB1: Select instrument" appears in the middle panel), on the right side, select the instrument (your OB1 pressure controller should appear when clicking on "Instrument") and "load the configuration" zero pressure or flow rate.

3       30 s       ×         4       DIST       Distrib Set valve: 2       ×         5       30 s       ×         6       DIST       Distrib Set valve: 3       ×         8       DIST       Distrib Set valve: 3       ×         1       8       DIST       Distrib Set valve: 4       ×         1       8       DIST       Distrib Set valve: 4       ×         10       GO       Go to: 6 - 5 time - Left: 5/5       ×         11       10       Go to: 6 - 5 time - Left: 5/5       ×
4         DIST         Distrib Set valve: 2         ×           5         30 s         ×           6         DIST         Distrib Set valve: 3         ×           7         1         1         min         ×           8         DIST         Distrib Set valve: 4         ×           9         4 s s         ×         ×           10         Go         Go to: 6 - 5 time - Left: 5/5         ×
5       30 s       ×         6       DIST       Distrib Set valve: 3       ×         7       Image: Set valve: 4       ×         8       DIST       Distrib Set valve: 4       ×         9       Image: Association of the set valve: 5/5       ×         10       Good Good to: 6 - 5 time - Left : 5/5       ×
6       DIST       Distrib Set valve: 3       ×         7       1       min       ×         8       DIST       Distrib Set valve: 4       ×         9       45 s       ×         10       GO       Go to: 6 - 5 time - Left : 5/5       ×
7       1       min       ×         8       DIST       Distrib Set valve: 4       ×         9       45 s       ×         10       GO       Go to: 6 - 5 time - Left : 5/5       ×
1         8         DIST Distrib Set valve: 4         ×           9         •         45 s         ×           10         GO         Go to: 6 - 5 time - Left : 5/5         ×
9         45 s         ×           10         GO         Go to: 6 - 5 time - Left : 5/5         ×
X 10 GO Go to: 6 - 5 time - Left : 5/5 X
11 END End X

of

On the left side of the sequence window, click on the blue "END" box (a new line "END" appears). This means that your sequence is over.

**13** P

Press the "Play" button at the top of the window. Your sequence will automatically run.

Sequence	2			
ADD			(iiii) 🖸 🗂 🗐	
GO		OB1 Seq_Inj - Load: "OB1Seq_Inj_1"		×
IF		DIST Distrib Set valve: 1		×
		30 s		×
SUB		DIST Distrib Set valve: 2		×
MOD		30 s		×
OB1		DIST Distrib Set valve: 3		×
AF1		S 1 min		×
MUX		DIST Distrib Set valve: 4		×
END		€ 45 s		×

![](_page_27_Picture_1.jpeg)

You can change the order of the different steps by just changing their position in the list. However, be aware that the steps you are targeting (for example when doing a loop) are not automatically updated.

![](_page_27_Picture_3.jpeg)

## JP

You can save the sequence by clicking on the "Save" button on top of the sequence window. You can also load a previously saved sequence. To perform the loading correctly, all the instruments used when the sequence was created should be connected to the ESI software.

## JP

You can stop the sequence when it is running without waiting until the end by clicking on the "Stop" button on top of the sequence window. However, be aware that doing so, you will not stop the command on the OB1 but only stop running the sequence. The OB1 configuration will remain the one that was active when the sequence was stopped. To put the pressure/flow rate back to zero, you need to do it manually by going to the OB1 window.

#### Integration into larger systems using SDK or TTL

It is possible to **use SDK libraries to control the OB1 MK3**+ and other Elveflow instruments with your own code and involve third party instruments such as microscopes, temperature control systems, etc. Contact us at **contact@elveflow.com** for more information.

#### REFER TO ANOTHER USER GUIDE

![](_page_27_Picture_11.jpeg)

## Appendix 5

## Serialization/scale up - working with more than 12 solutions

#### From 1 to 12 solutions

If you plan to **increase the number of injected solutions**, prepare more reservoirs and connect them to the manifold and the MUX Distribution as presented in section "MUX Distribution connection and preparation".

You can work with **up to 12 solutions connected to a single MUX Distribution**. When using an automated sequence, you will have to add more steps in the sequence to inject the new solutions.

#### From 13 to 23 solutions

If the experiment requires the injection of **more than 12 solutions**, it is possible to work with **two MUX Distributions connected in series**, meaning that the outlet of the first MUX Distribution is connected to one inlet port of the second MUX Distribution.

Using a single pressure channel from the OB1 pressure controller, it is then possible to inject up to 23 solutions.

When working with more than one MUX Distribution, you will have to open one MUX Distribution window for each instrument. We recommend giving each MUX Distribution and each solution a different name.

![](_page_28_Figure_1.jpeg)

#### From 24 to 144 solutions

If the objective is to scale up your experiment significantly, it is possible to work with up to nearly 150 solutions by using 2 stages of Distribution valves and connect the outlets of the first set to the inlets of the second, as illustrated in the schematic below.

It is worth noting that up to 16 instruments can be connected to the ESI software. It is then possible to connect 15 MUX Distributions at the same time and an OB1 pressure controller.

If you add a line of pressure to the manifold, the pressure in the reservoirs will remain unchanged.

![](_page_28_Figure_7.jpeg)

## دال

In order to ensure comparable flow rate conditions in the microfluidic device for all injected solutions at a given pressure, we recommend using the same length of tubing for all the microfluidic lines. To ensure a good control of the flow rate, the best solution remains the feedback loop with a sensor connected to the pressure controller (refer to appendix 2 for more information).

![](_page_29_Figure_1.jpeg)

#### **Regulator mode**

When the valve rotates from port 1 to a port blocked by a plug fitting, using the mode "shortest" of the MUX Distribution, the flow rate stabilizes faster at zero ("Plugged port" curve) compared to the experiment where the applied pressure is set to zero ("Zero pressure" curve).

In the automated sequence below, step 5 was used to select a blocked port (valve 12). The response time is shown as "Plugged port" in the accompanying graph. The result of replacing this step by an OB1 command to apply zero pressure is shown as the trace "Zero pressure".

Switching between two non consecutive ports (one open and one blocked) does not impact the reactivity of the flow ("Non consecutive port" curve).

![](_page_29_Picture_6.jpeg)

![](_page_29_Figure_7.jpeg)

#### Sensor mode

Stopping the flow by rotating the valve to a blocked port ("plugged port" curve) is more efficient compared to applying a zero flow condition ("zero flow" curve).

$\bigcirc$		[] 🗗 🗂]
GO	1 🔀 Start Graph	
IF	2 OB1 Seq_Inj - Load: "OB1Seq_Inj_1'	
	3 DIST Distrib Set valve: 1	
SUB	4 🕥 15 s	
MOD	5 OB1 Seq_Inj - Load: "OB1Seq_Inj_1'	
OB1	6 DIST Distrib Set valve: 12	
AF1	7 💽 15 s	
MUX	8 🔀 Stop Graph	
END	9 OB1 Seq_Inj - Load: "OB1Seq_Inj_1'	

![](_page_29_Figure_11.jpeg)

If you are controlling the flow with the sensor mode, be aware that in this mode, the OB1 pressure controller regulates the pressure to keep the flow rate stable at a particular value. When the rotary valve is positioned on the blocked port, the flow will stop and the flow rate will be close to zero. However, the pressure on the OB1 will keep increasing in order to counterbalance this situation and try to keep the flow rate at the targeted value.

![](_page_30_Figure_2.jpeg)

## Optimization of your sequential injection system using valves

In its product range, in addition to the MUX Distribution rotary valve, Elveflow also offers **2/2 and 3/2 valves**, controlled with a MUX Wire valve controller, as solutions for switching the flow.

Refer to **appendix 1 "Microfluidic connector guide**" to learn how to connect the valves and the MUX Wire

The valves can be added to the sequential injection system in order to add functionalities and fulfill some experimental requirements. The 2/2 valve has 2 ports and and allows the switching of flow on and off. The 3/2 valve has 3 ports and enables the direction of fluid to or from different microfluidic lines.

![](_page_30_Picture_7.jpeg)

In both cases, the liquid can pass through the valves  $% \left( {{{\mathbf{r}}_{\mathbf{r}}}_{\mathbf{r}}} \right)$  in one direction or the other without.

#### Avoid large diffusion effects in the tubing

In order to decrease the effect of diffusion in the tubing, we recommend adding a 3/2 valve between the flow sensor and the microfluidic device (see the schematic). With this valve, a rapid flush is possible and hence the change of solution in your tubing will be quicker.

This configuration is also interesting in order to quickly flush air bubbles out of the microfluidic line.

![](_page_30_Figure_12.jpeg)

#### Flushing the device/collecting the sample in different outlets

For some experiments, it can be useful to flush the device between each injection, e.g. to clean the device or avoid cross contamination. By adding a 3/2 valve (3 ports, 2 ways) controlled by a MUX Wire at the outlet of the device, you can direct the fluid coming from the device in two different directions (e.g. a sample collection reservoir or a waste reservoir) or collect your samples in two different reservoirs. With the addition of this valve, it is possible to flush a solvent connected to the MUX Distribution through the device, then to rinse the entire microfluidic line and direct the solution to the waste.

![](_page_31_Figure_3.jpeg)

#### Parallelization

By adding a manifold at the outlet of the flow sensor, it is possible to increase the number of devices in which the solutions from the MUX Distribution are injected. It is then possible to parallelize numerous devices (the number depending on the type and number of manifolds chosen).

![](_page_32_Figure_3.jpeg)

## Appendix 8 Work with tiny volumes

If you plan to inject tiny volumes (10's of uL) in the microfluidic devices, consider preloading the tubing with a syringe and then using a pressurized reservoir filled with a buffer solution or no solution at all to push the targeted volume in the device.

This method avoids the need for excess reagent simply to fill the reservoir.

![](_page_33_Figure_4.jpeg)

## Appendix 9 Lower

### Lower the impact of the mechanical switch

If the overshoot of the flow rate resulting from the mechanical switch of the rotary valve is impacting the accuracy of your experiment and you want to get rid of this effect, we advise you to add a 2/2 valve (on/off valve) between the MUX Distribution and the flow sensor. By closing the 2/2 valve

![](_page_34_Figure_4.jpeg)

before applying the rotation of the MUX Distribution valve, and opening it again once the rotation is completed, the flow rate will be impacted less by the switch.

Below shows a comparison test using a simple automated sequence with and without the use of valves. The flow rate was fixed at 400  $\mu$ L/min and the Distribution valve was rotated from port 1 to port 2 and then to port 3. The 2/2 valve was closed right before the rotation and opened again right after. The table below shows the mean switching time and range of flow rate for the overshoot. The overshoot in flow rate decreased significantly (77% reduction) when a 2/2 valve was added to the setup, demonstrating its utility in this setup.

	Switching time (s)	Range (µL/min)
No valve	2,33 ± 0,41	594,9 ± 297,6
2/2 valve	1,33 ± 0,41	135,6 ± 55,4

![](_page_34_Figure_8.jpeg)

A similar improvement can be obtained using a more complex automated sequence. In this example, the rotary valve was used to select a different liquid every 10s and flow rate was increased every 20s over the range 50 uL/min to 1000 uL/min. Addition of the 2/2 valve significantly decreased the impact of the mechanical switch of the rotary valve on the flow rate.

1	1	$\geq$	Start Graph
		OB1	Seq_Inj - Load: "OB1Seq_Inj_1"
		MUX	Wire_Se Load: "MUXWire "
	4	DIST	Distrib Set valve: 1
		MUX	Wire_Se Load: "MUXWire "
		$\overline{\mathbf{b}}$	30 s
		MUX	Wire_Se Load: "MUXWire "
	8	DIST	Distrib Set valve: 2
		MUX	Wire_Se Load: "MUXWire "
	10	$\overline{\mathbf{O}}$	30 s
	11	MUX	Wire_Se Load: "MUXWire "
	12	DIST	Distrib Set valve: 3
	13	MUX	Wire_Se Load: "MUXWire"
	14	$\overline{\mathbf{O}}$	1 min
	15	MUX	Wire_Se Load: "MUXWire "
	16	DIST	Distrib Set valve: 4
	17	MUX	Wire_Se Load: "MUXWire"
	18	$\odot$	45 s
	19		Stop Graph
	20	OB1	Seq_Inj - Load: "OB1"
	21	END	End

![](_page_34_Figure_11.jpeg)

1

2

## Appendix 10 Automated control of the injected volume using the "flow integration" module

The aim of this section is to detail the use of the "flow integration" module in an automated sequence in order to directly control the injected volumes.

Before reading this appendix, we advise you to refer to appendix 4 in order to learn the basics of automation with the ESI sequencer.

To create a sequence, click on the top middle button "Create Sequence" of the main window of the ESI software: the sequence window appears.

Create a step to record the data of your experiment with the Graph box (optional). Create a step for the OB1 (control in pressure or flow rate) and a step for the MUX Distribution in order to select the port corresponding to the solution to inject as described in appendix 4.

On the sequence window: on the left side of the window, click on **the blue "MOD" box** (a line "MOD" appears), on the right side, **select the instrument** (your OB1 pressure controller should appear when clicking on "Instrument") and **choose the right module**, here "Flow integration".

Click on the "Edit module settings" button. A new window will appear. Select the reservoir type used, indicate the actual volume of solution in the reservoir and the targeted volume. Don't click on the play button as it will be automatically triggered in the sequence.

![](_page_35_Picture_8.jpeg)

![](_page_35_Picture_9.jpeg)

If several sensors are connected to the OB1, an additional window will appear when clicking on the "Edit module settings" button in order to select the channel to which you want to apply the module.

3

![](_page_35_Picture_11.jpeg)

On the left side of the sequence window, **click on the "Wait" box** (clock symbol) and a new line with a time frame appears: **set a duration of 10 ms**.

ADD C C C C C C C C C C C C C C C C C C C	Seq.Inj
60     1     Image: Start Graph     X       1F     2     0B1     Seq_lnjLoad: "0B1Seq_lnj_1"     X	Seq_Inj
IF         2         OB1         Seq_Inj - Load: "OB1Seq_Inj_1"         X           TRIG         2         Transformation         X	Seq_Inj
Type of condition	
3 DIST Distrib Set valve: 1 X System	on Module
SUB 4 MOD Flow Integration × Step	p where module vas initialised
MOD 5 S 10 ms X Module	Flow Integration
OB1 6 IF Seq_Inj - Mod step : 4 - Go to: 8 - ELSE continue × Volu	ime was dispensed (ml) :
AF1	0.6
MUX	
DIST	ue Go to step 8 Else go to next step
END	

On the left side of the sequence window, **click on the blue "IF" box.** A new step will appear. The goal of this step is to check if the volume to be dispensed has been reached or not.

On the right side, **select the instrument** (your OB1 pressure controller should appear when clicking on "Instrument"). **Choose the type of condition** ("Module" in this case), indicate the step number where the module was initialised (step 4 in the example) and the targeted corresponding volume of the initialisation step. Indicate also the next step to go in the sequence when the targeted volume is reached ("If true go to step 8 in this example"). At this point, if the targeted volume is not reached yet, the sequence will go to the step right after.

## JP

If you are using multiple modules or if you change the position of the steps during the creation of the sequence, be aware that the information regarding the targeted steps are not automatically updated. Always check one last time that the numbers and the targeted steps match your requirements before starting the sequence.

4

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On the left side of the sequence window, **click on the blue "GO" box**. A new step will appear. This step allows you to create a loop in the sequence. As long as the volume is not reached, the sequence will stay in the loop; once the volume is reached, it will get out of the loop and keep going (this condition on the volume is checked in the "IF" step).

Choose and indicate **the number of the "target step"** (here, the wait step 5, in order to create a loop on the module command and keep injecting volume).

![](_page_36_Picture_4.jpeg)

Indicate also in the **"time" area** how many times you want to repeat the loop. We recommend using a very high number to ensure that the targeted volume is reached before the loop is exited.

6

![](_page_36_Figure_6.jpeg)

![](_page_36_Figure_7.jpeg)

**CONGRATULATIONS**, YOU HAVE NOW MASTERED THE AUTOMATED INJECTION OF PRECISE VOLUMES! Repeat the successive steps "OB1", "DIST", "MOD", "Wait", "IF" and "GO" as many times as you like for all the solutions you want to inject.

In this example, we inject 0.1 mL of the solution connected to port 1 at 700 mbar and then 0.1 mL of the solution connected to port 2 at 500 mbar.

The flow is automatically maintained at 0 at the end of the sequence once the right volume has been injected.

![](_page_36_Picture_12.jpeg)

Once the targeted volume is injected with the module "Flow integration", the channel is configured to maintain the flow at 0. Hence, if you want to inject another solution, you need to add a new line of command for the OB1 after the loop for the module "Flow integration", even if the configuration of the OB1 remains the same.

> Before launching the sequence again, you need to close all the "Flow integration" module windows and reinitialize the "MOD" step. Go to the button "Edit module settings" and press the reinitialisation button. The injected volume will be set again to 0.

Repeat the same operation for all the "MOD" steps. Otherwise, the sequence will not run correctly and the solution will not be injected as the injected volume will already be equal to the targeted volume.

This user guide was conceived, written and developed within the framework of the **ElectroMed project**. This project has received funding from the European Union's Horizon 2020 research and innovation programme under grant agreement **No 862539**. **ELECTRO** Med

![](_page_36_Picture_18.jpeg)

## Supplementary information

#### Conditions of use

#### Terms and conditions of use

We strongly believe in the intrinsic quality of our microfluidic instruments line and we hope that you will be pleased with your purchase. However, in the unlikely event that you should receive damaged or incorrect goods in your delivery, please notify us within 7 days.

You will be offered the option of a refund or an exchange (provided the goods are in stock).

You may be asked to return goods for inspection. In this case we will refund the shipping fees.

Should the damaged or incorrect item be no longer available, you will be given the option of a refund. Please note that goods that become damaged or broken after 7 days of receipt cannot be returned.

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If for any reason you do not wish to keep your purchase and would like a store credit, then please notify us within 7 days.

We cannot accept unwanted returns that have been opened, used or damaged by the customer.

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Please note that we are unable to refund your costs in returning unwanted goods or the delivery costs of sending the goods to you in the first place.

#### Cancellations

If you wish to cancel your order please email us immediately: contact@elveflow.com.

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Customer details remain private and confidential and will not be released to a third party unless required to do so by law.

We use the information we collect about you to process orders, to provide a more personalized shopping experience and, if you request it, to notify you about new products, special offers or other information that may be of interest to you. We do not sell or pass on any personal information to any other Companies or Organizations.

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Payment from private customers must be paid upfront. Trade orders from registered companies or organizations can be invoiced. Payment is due strictly within 30 days of the invoice date.

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Please note that some goods may vary in style, color or detail from the image shown. We reserve the right to change prices at any time.

#### Transport and storage

Be careful not to harm or shake Elveflow<sup>®</sup> products while moving. Elveflow<sup>®</sup> products must not be transported when plugged in. Store products in standard conditions in an adapted box (typically the one used to send you the product).

Humidity and temperature must not exceed those of the specifications.

#### **Exclusive remedies**

The remedies provided herein are the customer's sole and exclusive remedies. Elveflow® shall not be liable for any direct, indirect, special, incidental, or consequential damages, whether based on contract, tort, or any other legal theory.

#### Safety Information

THE FOLLOWING GENERAL SAFETY PRECAUTIONS MUST BE FOLLOWED DURING ALL PHASES OF OPERATION, SERVICE, AND REPAIR OF THIS INSTRUMENT. FAILURE TO COMPLY WITH THESE PRECAUTIONS OR WITH SPECIFIC WARNINGS ELSEWHERE IN THIS MANUAL VIOLATES SAFETY STANDARDS OF DESIGN, MANUFACTURE, AND INTENDED USE OF THE INSTRUMENT. ELVESYS ASSUMES NO LIABILITY FOR THE CUSTOMER'S FAILURE TO COMPLY WITH THESE REQUIREMENTS.

#### Important advice

#### Pressurized Equipment

Elveflow<sup>®</sup> products are for research use only.

No liquid should get into the OB1, otherwise this would void the warranty.

The pressure source connected to the OB1 must be dry, dust and oil free, and of a maximum of 10 bar. Please take the required action to ensure that these conditions are met and maintained.

#### Conditions of use

This instrument is intended for indoor use. It is designed to operate at a maximum relative humidity of 60% and at altitudes of up to 2000 meters. Operating temperature range is +5 °C to 50 °C.

Do not operate in wet/damp conditions: to avoid electric shock, do not operate this product in wet or damp conditions.

Do not operate in an explosive environment. Do not operate the equipment in the presence of explosive or flammable gases or fumes.

Warning: Do not use this product as safety or emergency stop devices or in any other application where failure of the product could result in personal injury. The protective features of this product may be impaired if it is used in a manner not specified in the operating instructions. Before installing, handling, using or servicing this product, please consult the data sheet and user manual.

Failure to comply with these instructions could result in death or serious injury. If the buyer purchases or uses Elveflow® products for any unintended or unauthorized application, the buyer shall defend, indemnify and hold harmless Elveflow® and its officers, employees, subsidiaries, affiliates and distributors against all claims, costs, damages and expenses, and reasonable attorney fees arising out of, directly or indirectly, any claim of personal injury or death associated with such unintended or unauthorized use, even if Elveflow® is allegedly negligent with respect to the design or the manufacture of the product. Care must be taken when the Elveflow<sup>®</sup> pump is pressurized to ensure that the instrument is not damaged in any way.

#### Protection

Safety glasses and lab coats should be worn at all times when using an Elveflow<sup>®</sup> pressure pump due to the use of pressurized equipment. This is particularly important when hazardous liquids are used.

#### Electrictity Advice

Use Elveflow® instruments with the provided power unit only. Maintenance should only be attempted by qualified Elveflow® personnel. Removal of the back panel may invalidate any warranty.

Before applying power: verify that the line voltage matches the product's input voltage requirements and that the correct fuse is installed. Use only the specified line cord for this product and make sure the line cord is certified for the country of use.

Fuses: only fuses with the required rated current, voltage, and specified type (normal blow, time delay, etc.) should be used. Do not use repaired fuses or short-circuited fuse holders. To do so could cause a shock or fire hazard.

Keep away from live circuits: operating personnel must not remove instrument covers. Component replacement and internal adjustments must be made by qualified service personnel. Do not replace components with a power cable connected. Under certain conditions, dangerous voltages may exist even with the power cable removed.

To avoid injuries, always disconnect power, discharge circuits and remove external voltage sources before touching components.

ESD precautions: the inherent design of this component causes it to be sensitive to electrostatic discharge (ESD). To prevent ESDinduced damage and/or degradation, take customary and statutory ESD precautions when handling this product.

#### Maintenance advice

Maintenance should only be attempted by qualified Elveflow® personnel. Removal of the back panel will invalidate any warranty.

Do not service or adjust alone: do not attempt internal service or adjustment unless another person, capable of rendering first aid and resuscitation, is present.

Do not substitute parts or modify the instrument: because of the danger of introducing additional hazards, do not install substitute parts or perform any unauthorized modification to the instrument.

Return the instrument to an Elveflow® Technologies Sales and Service Office for service and repair to ensure that safety features are maintained.

Instruments which appear damaged or defective should be made inoperative and secured against unintended operation until they can be repaired by qualified Elveflow® personnel.

#### CE compliance

This product meets the essential requirements of applicable European Directives, as amended for CE marking, as follows:

#### Electromagnetic Compatibility

COUNCIL DIRECTIVE 89/336/EEC of 3 May 1989

This directive has been amended by the following Council Directives:

1. 92/59/eec of 29 June 1992 (General Product Safety)

2. 93/68/eec of 22 July 1993 (CE Marking directive)

3. 99/5/ec: Directive of Radio Equipment & Telecommunications Terminal Equipment (R&TTE).

![](_page_39_Picture_0.jpeg)

Technical support

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<u>www.elveflow.com</u>

duct:

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![](_page_39_Picture_7.jpeg)

MAY THE FLOW BE WITH YOU